Notice of References Cited	Application/Control No. 10/670,172	Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Gary Mui	Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,072,809	06-2000	Agrawal et al.	370/503
*	B	US-7,142,517	11-2006	Tseng et al.	370/252
*	C	US-2002/0176361	11-2002	Wu et al.	370/231
*	D	US-2003/0112758	06-2003	Pang et al.	370/235
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Zeidler, J.R.; "Performance analysis of LMS adaptive prediction filters"; Proceedings of the IEEE□□Volume 78, Issue 12, Dec. 1990 Page(s):1781 - 1806
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.